APR 1 1 2002 of IN THE UNITED STATE Applicant : Shinji Maekawa

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2813

Serial No.: 09/724,403 Examiner:

Yennhu B. Huynh

Filed : N

: November 27, 2000

Title : SEM

: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

Commissioner for Patents Washington, D.C. 20231

el. 1-32

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Official Action mailed January 29, 2001, Applicant elects the invention of Species I: claims 1-32, drawn to a method of manufacturing a semiconductor device. The election is made without traverse.

AMENDMENT

Kindly amend the above-referenced application as follows.

In the Claims:

Please amend the claims as follows.

1. (Amended) A method of manufacturing a semiconductor

04/15/2002 GGEBREGI 00000025 09724403

01 FC:103

02 FC:115

288.00 OP 110.00 OP CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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